


Search Notes 	Application/Control No. 10573458	Applicant(s)/Patent Under Reexamination OTSUKA ET AL.
	Examiner CHRISTOPHER M ROLAND	Art Unit 2893

SEARCHED

Class	Subclass	Date	Examiner
257	745, E29.144, E29.149	4 May 2008	CMR
438	571	4 May 2008	CMR
257	11, 14, 200, 201, 471, 473, 615, E33.023, E33.049, E31.019, E29.089, E21.085, E21.173 (text-limited)	4 May 2008	CMR
438	167, 570, 604 (text-limited)	4 May 2008	CMR
257	745, E29.144, E29.149	17 Nov. 2008	CMR
438	571	17 Nov. 2008	CMR
257	11, 14, 200, 201, 471, 473, 615, E33.023, E33.049, E31.019, E29.089, E21.085, E21.173 (text-limited)	17 Nov. 2008	CMR
438	167, 570, 604 (text-limited)	17 Nov. 2008	CMR
257	745, E29.144, E29.149	25 Apr. 2009	CMR
438	571	25 Apr. 2009	CMR

SEARCH NOTES

Search Notes	Date	Examiner
(see EAST search history)	4 May 2008	CMR
Consulted Anh Mai, Primary Examiner, USPTO GAU 2814	6 May 2008	CMR
(see IEEE Xplore search history)	7 May 2008	CMR
(see updated EAST search history)	17 Nov. 2008	CMR
(see IEEE Xplore search history)	18 Nov. 2008	CMR
Consulted Davienne Monbleau, Supervisory Patent Examiner, USPTO GAU 2893	20 Nov. 2008	CMR
(see updated EAST search history)	25 Apr. 2009	CMR
(see IEEE Xplore search history)	28 Apr. 2009	CMR
Consulted Davienne Monbleau, Supervisory Patent Examiner, USPTO GAU 2893	1 May 2009	CMR

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner

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